Form PTO 1449 (Modified)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO. 242820US2RD		SERIAL NO. New Application			
(woulded)									
LISTOF	BEEE	SENCES CITED BY ADI	DISCANT	APPLICANT					
LIST OF REFERENCES CITED BY APPLICANT				Yoshiaki SAITO, et al.	Ţ				
			5	FILING DATE		GROUP			
Herewith									
U.S. PATENT DOCUMENTS									
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB FILING DATE CLASS IF APPROPRIATE			
	AA	5,659,499	08/19/97	E. CHEN, et al.					
	AB	5,956,267	09/21/99	A. T. HURST, et al.					
	AC	5,734,605	03/31/98	X. T. ZHU, et al.	ļ				
	AD	5,640,343	06/17/97	W. J. GALLAGHER, et al.					
	AE	5,940,319	08/17/99	M. DURLAM, et al.					
	AF	6,351,408	02/26/2002	S. SCHWARZL, et al.					
	AG				<u> </u>				
	AH								
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	AL				 				
	AM		<u> </u>						
	AN		<u> </u>		<u> </u>	L			
			FO	REIGN PATENT DOCUMENTS					
		DOCUMENT NUMBER	DATE	COUNTRY	NTRY		TRANSLATION		
	AO	WO 00/10172	02/24/2000	WIPO (with English Abstract)		YES NO			
	AP	10-4227	01/06/98	JAPAN (with English Abstract)	Abstract)			X	
	AO	WO 99/14760	03/25/99	WIPO (with English Abstract)				X	
	AR	197 44 095	04/15/99	WIPO (with corr. US 6,351,408)				х	
	AS								
	AT								
	AU			 					
		OTHER RE	FERENCES (Including Author, Title, Date, Pertinen	t Pages, e	tc.)			
	AV	J. S. MOODERA, et al., "FERROMAGNETIC-INSULATOR-FERROMAGNETIC TUNNELING: SPIN-DEPENDENT							
	AW	L. F. SCHELP, et al., "SPIN-DEPENDENT TUNNELING WITH COULOMB BLOCKADE", Vol. 56, No. 10, pgs. R5747-R5750, Physical Review B, September 1, 1997							
	AX	Y. SAITO, et al., "SPIN-DEPENDENT TUNNELING THROUGH LAYERED HARD-MAGNETIC-NANO-PARTICLES", Vol. 23, No. 4-2, pgs. 1269-1272, J. Jpn. Appl. Magn. Society, 1999 (with English Abstract)							
	AY	F. MONTAIGNE, et al., "ENHANCED TUNNEL MAGNETORESISTANCE AT HIGH BIAS VOLTAGE IN DOUBLE-BARRIER PLANAR JUNCTIONS", Vol. 73, No. 19, pgs. 2829-2831, Applied Physics Letters, November 9, 1998							
	AZ	HEIGHT, AND DC BIA	SAITO, et al., "CORRELATION BETWEEN BARRIER WIDTH, BARRIER IEIGHT, AND DC BIAS VOLTAGE DEPENDENCES ON THE IAGNETORESISTANCE RATIO IN Ir-Mn EXCHANGE BIASED SINGLE IND DOUBLE TUNNEL JUNCTIONS", Vol. 39, pgs. L1035-L1038, Jpn. J. ppl. Phys., 2000						
Examiner						Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									
conformance	and no	ot considered. Include co	opy of this forn	n with next communication to applicant.					

Docket No.

242820US2RD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yoshiaki SAITO, et al.

SERIAL NO: New Application

GAU:

FILED:

Herewith

EXAMINER:

FOR:

MAGNETIC MEMORY

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland Registration Number 21,124

Customer Number

22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03) Docket No. 242820US2RD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yoshiaki SAITO, et al.

SERIAL NO: New Application GAU:

FILED: Herewith EXAMINER:

FOR: MAGNETIC MEMORY

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yoshiaki SAITO, et al.

SERIAL NO: New Application

FILED: HEREWITH

FOR: MAGNETIC MEMORY

STATEMENT OF RELEVANCY

Reference AA (US 5,659,499) on PTO Form 1449:

This reference shows the similar wiring with ferromagnetic-cladding layer. However, the structure of the ferromagnetic-cladding layer is different from our patent

Reference AB (US 5,956,267) on PTO Form 1449:

This reference shows the similar wiring with ferromagnetic cladding layer. However, the structure of the ferromagnetic cladding layer is different from our patent.

Reference AE (US 5,940,319) on PTO Form 1449:

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Reference AO (WO 00/10172) on PTO Form 1449:

This reference shows the similar wiring with ferromagnetic cladding layer. However, the structure of the ferromagnetic cladding layer is different from our patent.

Reference AP (JP 10-4227) on PTO Form 1449:

This reference shows RAM having magnetic tunneling junction element.

Reference AR (DE 197 44 095) on PTO Form 1449:

This reference shows a magnetic random access memory having a MOSFET.